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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : Atty Docket: 97-CCP-251 DIV  
Eric GERRITSEN et al. : APPLICATIONS BRANCH  
Serial No.: (not yet assigned) :  
Filed: Herewith :

For: *PROCESS FOR FORMING A LOW RESISTIVITY TITANIUM  
SILICIDE LAYER ON A SILICON SEMICONDUCTOR SUBSTRATE  
AND THE RESULTING DEVICE*

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09/858400  
05/16/01

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